Docket No.: MICRON.123DVC2

INFORMATION DISCLOSURE STATEMENT

Applicant : Robert J. Hanson

App. No : 10/826,660

Filed : April 16, 2004

For : PROTECTIVE LAYER FOR

CORROSION PREVENTION DURING

LITHOGRAPHY AND ETCH

Examiner : Unknown

Art Unit : 1756

CERTIFICATE OF MAILING

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

January 17, 2005
(Patc)
Sabing 11, Lee, Neg. No. 43,745

Mail Stop Amendment

Commissioner for Patents P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

Enclosed is an Information Disclosure Statement by Applicant (PTO/SB/08 equivalent) listing 11 references that are of record in related U.S. Patent No. 6,387,600, issued May 14, 2002; U.S. Patent No. 6,548,227, issued April 15, 2003; and U.S. Patent 6,759,181, issued July 6, 2004. Therefore, copies of these references are not submitted pursuant to 37 C.F.R. § 1.98(d).

This Information Disclosure Statement is being filed before the receipt of a first Office Action on the merits, and presumably no fee is required. If a first Office Action on the merits was mailed before the mailing date of this Statement, the Commissioner is authorized to charge the fee set forth in 37 C.F.R. § 1.17(p) to Deposit Account No. 11-1410.

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

> Registration No. 43,745 Attorney of Record

Customer No. 20,995 (949) 760-0404 Docket No.: MICRON.123DVC2

January 17, 2005 Page 1 of 1

Please Direct All Correspondence to Customer Number 20,995



TRANSMITTAL LETTER INFORMATION DISCLOSURE STATEMENT

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Mail Stop Amendment

Commissioner for Patents P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

Enclosed for filing in the above-identified application are:

(X) An Information Disclosure Statement and PTO/SB/08 equivalent listing 11 references for consideration.

(X) Return prepaid postcard.

The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment, to Account No. 11-1410.

SABING H. LEE

Registration No. 43,745 Attorney of Record Customer No. 20,995 (949) 760-0404



SHEET 1 OF 1

	PTO/SB/08 Equivalent				
Application No.	10/826,660				
Filing Date	April 16, 2004				
First Named Inventor	Robert J. Hanson				
Art Unit	-1750				
Examiner	Unknown Jose Diaz				
Attorney Docket No.	MICRON.123DVC2				

U.S. PATENT DOCUMENTS					
Examiner Initials	Cite No.	Document Number Number - Kind Code (if known) Example: 1,234,567 B1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear
/JD/	1	5,478,766	12-26-1995	Park et al.	
	2	5,643,033	07-01-1997	Gnade et al.	
	3	6,387,600	05-14-2002	Hanson	
	4	6,548,227	04-15-2993	Hanson	
$\neg \vdash$	5	6.759.181	07-06-2004	Hanson	

FOREIGN PATENT DOCUMENTS						
Examiner Initials	Cite No.	Foreign Patent Document Country Code-Number-Kind Code Example: JP 1234567 A1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear	T¹
/JD/	6	JP 1024025	01-26-1989	Satoru et al.		
/JD/	7	JP 6236893	08-23-1994	Matsunaga et al.		
/JD/	8	JP 6347811A	12-22-1994	Hirose et al.		
/JD	/ 9	JP 9090415	04-04-1997	Yoshiko et al.		

NON PATENT LITERATURE DOCUMENTS				
Examiner Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T	
/JD/	10	J.E.A.M. van den Meerakker and W. R. ter Veen, "Reductive Corrosion of ITO in Contact with AI in Alkaline Solutions," J. Electrochem Soc., Vol. 139, No. 2, February 1992, pgs. 395-390.		
/JD.	11	HIROMI Nishino et al., "Anti-Corrosion Process for Al-ITO System with Electrolytic Development Solution," Sharo Technical Journal, No. 44, pp. 31-36		

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Examiner Signature	/Jose Diaz/	Date Considered	06/16/2008

*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.